



July 1, 2003

Applicants : Bruce M. WARNES et al.

For : CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

Serial No. : 09/950 012 Group: 1764

Filed : Sept. 10, 2001 Examiner: Leung

Confirmation No. 9232

Commissioner for Patents

P.O. Box 1450

Arlington, VA 22313-1450

Supplemental IDS

Dear Sir:

Applicants enclose a Form 1449 listing documents which were cited by the British Patent Office with respect to a corresponding British application based on Applicant's above identified US application.

Applicant petitions the examiner to consider and make of record the listed documents.

The Commissioner is authorized to charge any fee for this Supplemental IDS and petition to my deposit account No. 20-1124.

Respectfully submitted,

Edward J. Timmer Reg. No. 27,402

enclosures: Form 1449 and document copies

CERTIFICATE OF MAILING

 I hereby certify that this correspondence and enclosures are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents

P.O. Box 1450, Arlington, VA 22313-1450, on June 23, 2003.

Edward J. Timmer